



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Toyserkani et al.  
Appl. No. : 10/697,552  
Filed : 10/31/2003  
Title : SYSTEM AND METHOD FOR CLOSED-LOOP CONTROL OF LASER  
CLADDING BY POWDER INJECTION  
Grp./A.U. : 2125  
Examiner :

Docket No.: 14508

Honorable Assistant Commissioner of Patents  
Alexandria, VA 22313-1450

Sir:

**PTO CUSTOMER NO. 000293**

INFORMATION DISCLOSURE STATEMENT

In accordance with 37 C.F.R., §§ 1.97-1.99, applicant submits the following information which may be of interest to the examiner in charge of the above referenced application for patent. Only copies of the non-US references listed on the attached Form PTO-1449 are attached.

Respectfully submitted,

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FORM PTO-1449  
(Rev. 7-80)U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

Atty. Docket No. 14508

Serial No.  
10/697,552**LIST OF PRIOR ART CITED BY APPLICANT**  
(Use several sheets if necessary)

APPLICANT Toyserkani et al.

FILING DATE 10/31/2003 GROUP 2125

APR 19 2004

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AA	6 4 5 9 9 5 1	10/01/02	Griffith et al.			
AB	6 0 4 6 4 2 6	4/4/00	Jeantette et al.			
AC	5 6 5 9 4 7 9	8/19/97	Duley et al.			
AD	6 1 2 2 5 6 4	9/19/00	Koch et al.			
AE	5 5 1 7 4 2 0	5/14/96	Kinsman et al.			
AF						
AG						
AH						
AI						
AJ						
AK						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
AL		WO 01/36146	5/25/01	International			X	
AM								
AN								
AO								
AP								

## OTHER PRIOR ART (including Author, Title, Date, Pertinent Pages, Etc.)

AR		Japanese Patent Abstract 07108390 published 4/24/95 for CLADDING-MACHINING METHOD AND CLADDING MACHINE; Inventor - Shibata Kimihiro
AS		
AT		

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 602; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.